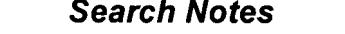


<b>Search Notes</b> 	<b>Application/Control No.</b> 10/634,279	<b>Applicant(s)/Patent under Reexamination</b> KIM, JU-HYUNG
	<b>Examiner</b> Ted M. Wang	<b>Art Unit</b> 2611

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
375	354	5/22/2007	TW
375	326, 327	5/22/2007	TW
375	355, 376	5/22/2007	TW